

APPLICATION DATA SHEET

Electronic Version v14

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Title of Invention	METHOD OF FABRICATING A SEMICONDUCTOR DEVICE
<p>Application Type : regular, utility Attorney Docket Number : NAUP0487USA1</p>	
<p>Correspondence address: Customer Number: 027765 </p>	
<p>Continuing Data: This is a Division of US application number 10/063,307, filed 2002-04-10 , now pending.</p>	
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as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.